

Facile fabrication of a flexible patterned film with diverse micro-/nanostructures via electrohydrodynamic patterning

Guowei Lv,^a Xiaobing Hu,^b Lu Hao,^a Hongmiao Tian,^c Jinyou Shao^c and Demei Yu^{a,*}

^a School of Chemistry, State Key Laboratory of Electrical Insulation and Power Equipments, MOE Key Laboratory for Non-Equilibrium Synthesis and Modulation of Condensed Matter, Xi'an Jiaotong University, Xi'an 710049, Shaanxi, P. R. China

^b College of Chemistry and Chemical Engineering, Shaanxi Province Key Laboratory of Phytochemistry, Baoji University of Arts and Sciences, Baoji 721013, Shaanxi, P. R. China

^c State Key Laboratory of Manufacturing Systems Engineering, Xi'an Jiaotong University, Xi'an 710049, Shaanxi, P. R. China

Film thickness vs rotational speed for SCPR film

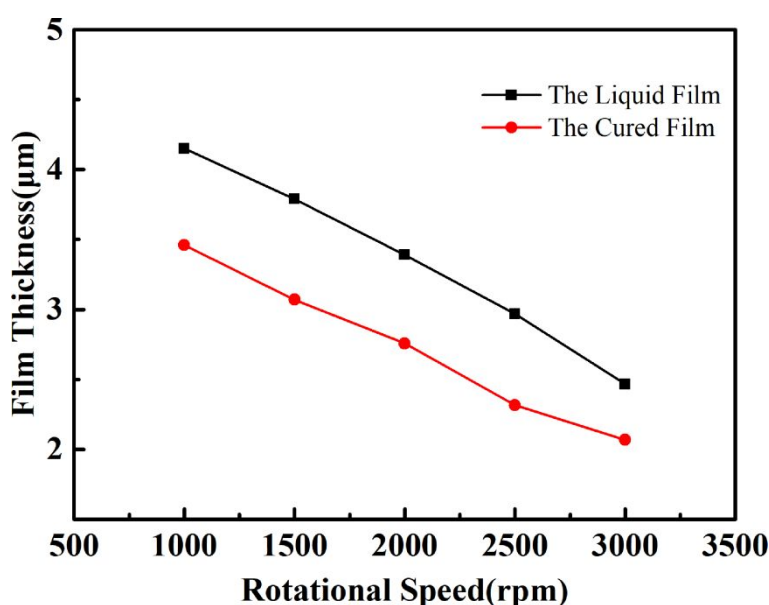


Fig. S1. h vs n for SCPR film with $n = 1000$ rpm, 1500 rpm, 2000 rpm, 25000 rpm and 3000rpm, respectively.

EHDP of SCPR

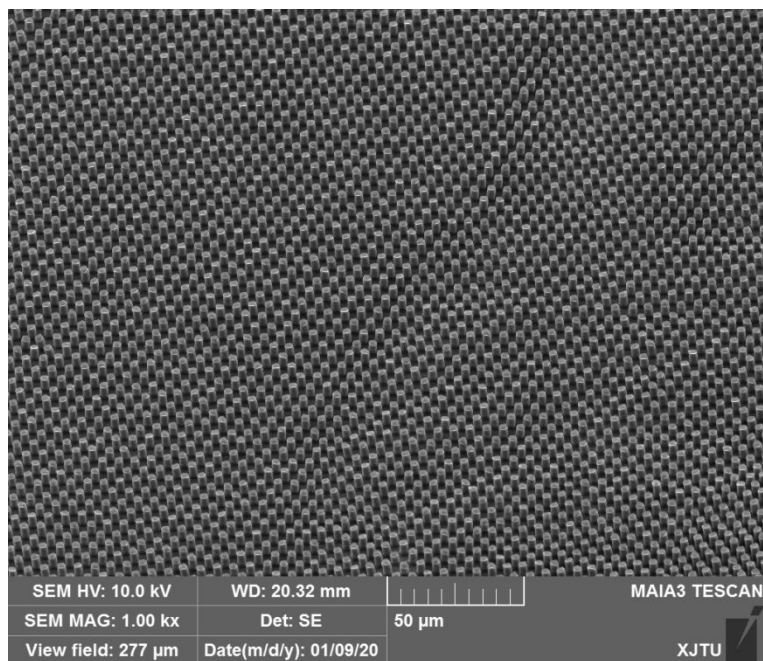


Fig. S2. SEM images of EAP on a flexible ITO-coated PET film for SCPR film.